**Product Specification** 1900.001514 30 April 2025 11:26:1 Issue Date

Part Number	rt Number Customer					
Category	egory Parameter		Specification	Measurement Method		
OverallWafer	1.0	Diameter	100.00 +/- 0.20 mm			
	2.0	Primary Flat Orientation	{110} +/- 1 degree	Customer supplied material		

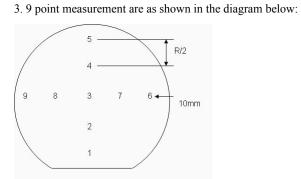
**Icemos Technology Ltd** 

Category		rarameter	Specification	Measurement Method
OverallWafer	1.0 Diameter		100.00 +/- 0.20 mm	
	2.0	Primary Flat Orientation	{110} +/- 1 degree	Customer supplied material
	3.0	Primary Flat Length	32.50 +/- 2.50 mm	Customer supplied material
	4.0	Secondary Flat Orientation	none or SEMI Standard	Customer supplied material
	5.0	Overall Thickness	411.00 +/- 6.00 μm	ADE, 100%
	6.0	Total Thickness Variation (TTV)	<3.00μm	Guaranteed by Process
	7.0	Bow	<60.00μm	ADE to ASTM F534, 100%
	8.0	Warp	<60.00μm	ADE to ASTM F534, 100%
	9.0	Edge Chips	0	Bright Light, 100%
	10.0	Edge Exclusion	5mm	
HandleSilicon	11.0	Handle Growth Method	CZ	Customer supplied material
	12.0	Handle Orientation	{100} +/- 0.5 degree	Customer supplied material
	13.0	Handle Thickness	400.00 +/- 5.00 μm	ADE, 100%
	14.0	Handle Doping Type	P	Customer supplied material
	15.0	Handle Dopant	Boron	Customer supplied material
	16.0	Handle Resistivity	0.01-0.05 Ohm-cm	Customer supplied material
	17.0	Backside Finish	Polished with oxide and lasermark. Handling marks allowed.	Guaranteed by process
BuriedOxide	18.0	Oxide Type	Thermal	
	19.0	Oxide Thickness	10,000.00 +/- 500.00 A	Nanospec centre point, 4%
	20.0	Oxide formed on	Device and/or Handle	
DeviceSilicon	21.0	Device Growth Method	CZ	Customer supplied material
	22.0	Device Orientation	{100} +/- 0.5 degree	Customer supplied material
	23.0	Nominal Thickness	10.00 +/- 1.00 μm	ADE single point, 100% (note3)
	24.0	Distance to device silicon edge from wafer edge	< 2mm	Typical by Process
	25.0	Device Doping Type	Р	Customer supplied material
	26.0	Device Dopant	Boron	Customer supplied material
	27.0	Device Resistivity	<0.0015 Ohm-cm	Customer supplied material
	28.0	Surface Voids	None	Bright Light, 100% (note2)
	29.0	Haze	None	Bright Light, 100% (note2)
	30.0	Scratches	none on the front-side	Bright Light, 100% (note2)

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Part Number		Customer			
Category	Parameter	Specification		M	leasurement Method
Shipping Details	Wafer per box :	Max 25			
	Packaging:	Taped Polypropylene Wafer Box Empak, Ultrapak, 100.00mm Antistatic Double Bagging			
	Lot Shipment Data	Device Thickness Bow / Warp Data Handle and SOI Thickness			
Explanatory Notes	1. Microscope inspec	ction performed using microscope sca	nn as below. 5x objec	ctive.	
	2. All bright light ins	pections performed exclude all wafer	area outside the edg	ge exclusion defin	ed in Overall

Wafer, Edge Exclusion. High intensity bright lamp inspection as per ASTM F523.



Additional Information